

<b>L Number</b>	<b>Hits</b>	<b>Search Text</b>	<b>DB</b>	<b>Time stamp</b>
<b>28</b>	<b>287</b>	(electromechanical or microelectromechanical or electromachin\$3 or MEMS or MEM) same ((metal or metallic or conduct\$4 or metalliz\$3) near3 (layer or coat\$3 or cover\$3 or plat\$3))	<b>EPO; JPO; DERWENT</b>	<b>2004/05/03 12:56</b>
<b>29</b>	<b>12</b>	((electromechanical or microelectromechanical or electromachin\$3 or MEMS or MEM) same ((metal or metallic or conduct\$4 or metalliz\$3) near3 (layer or coat\$3 or cover\$3 or plat\$3))) same (spring or web or flexure)	<b>EPO; JPO; DERWENT</b>	<b>2004/05/03 14:37</b>
<b>30</b>	<b>1532</b>	(electromechanical or microelectromechanical or electromachin\$3 or MEMS or MEM) same ((metal or metallic or conduct\$4 or metalliz\$3) near3 (layer or coat\$3 or cover\$3 or plat\$3))	<b>USPAT; US-PGPUB</b>	<b>2004/05/03 12:56</b>
<b>31</b>	<b>127</b>	((electromechanical or microelectromechanical or electromachin\$3 or MEMS or MEM) same ((metal or metallic or conduct\$4 or metalliz\$3) near3 (layer or coat\$3 or cover\$3 or plat\$3))) same (spring or web or flexure)	<b>USPAT; US-PGPUB</b>	<b>2004/05/03 14:04</b>
<b>32</b>	<b>41</b>	((electromechanical or microelectromechanical or electromachin\$3 or MEMS or MEM) same ((metal or metallic or conduct\$4 or metalliz\$3) near3 (layer or coat\$3 or cover\$3 or plat\$3))) same (wet near3 etch\$3)	<b>USPAT; US-PGPUB</b>	<b>2004/05/03 14:37</b>
<b>33</b>	<b>1</b>	("5639973").PN.	<b>USPAT</b>	<b>2004/05/03 14:18</b>
<b>69</b>	<b>287</b>	((electromechanical or microelectromechanical or electromachin\$3 or MEMS or MEM) same ((metal or metallic or conduct\$4 or metalliz\$3) near3 (layer or coat\$3 or cover\$3 or plat\$3))) and (wet near3 etch\$3)	<b>USPAT; US-PGPUB</b>	<b>2004/05/03 14:38</b>